

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Sadayoshi HORII et al.

Application No.: 10/529,466

Filed: May 2, 2005

Docket No.: 123373

For: MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE AND SUBSTRATE
PROCESSING APPARATUS

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

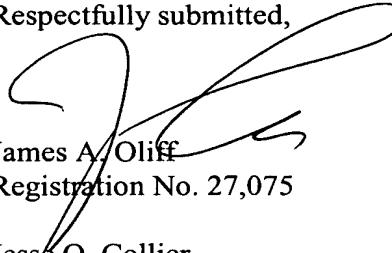
Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

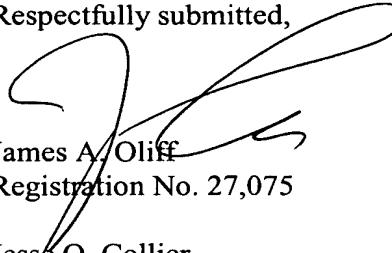
- 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- 2. Relevance of the non-English language references 2-5 are discussed in the present specification.
- 3. The references 1-2 and 6-9 were cited in the International Search Report. An English language version of the International Search Report is attached for the Examiner's information.
- 4. In accordance with 37 CFR §1.98(a)(2)(ii), copies of any U.S. patents and patent application publications are not attached.
- 5. English language Abstracts of the non-English language references 2-6 and 8-9 are attached hereto.



6. A computer-generated English language translation of the following Japanese Patent Publication has been obtained from the website of the Japanese Patent Office ([<http://www.jpo.go.jp>]), and is attached, but has not been reviewed for accuracy. See References 2-6 and 8-9.

Respectfully submitted,


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Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE	ATTY DOCKET NO. 123373	APPLICATION NO. 10/529,466		
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)		APPLICANTS Sadayoshi HORII et al.				
		FILING DATE May 2, 2005	GROUP			
		U.S. PATENT DOCUMENTS				
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
	1	5,953,634	9/14/1999	KAJITA et al.		
FOREIGN PATENT DOCUMENTS						
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS
	2	JP A 2002-173777 w/ abst & transl	6/21/2002	JAPAN		
	3	JP A 2002-175987 w/ abst & transl	6/21/2002	JAPAN		
	4	JP A 2000-121400 w/ abst & transl	4/28/2000	JAPAN		
	5	JP A 2002-004054 w/ abst & transl	1/9/2002	JAPAN		
	6	JP A 2002-164345 w/ abst & transl	6/7/2002	JAPAN		
	7	WO 01/36702 A1	5/25/2001	WIPO		
	8	JP A 2002-343790 w/ abst & transl	11/29/2002	JAPAN		
	9	JP A 2003-297814 w/ abst & transl	10/17/2003	JAPAN		
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)						
EXAMINER					DATE CONSIDERED	
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.						